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Electronic Patent Application Submission
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EFS ID: 66298
Application ID: 10800348 
Title of Invention: SILICON-ON INSULATOR (SOI)
SUBSTRATE HAVING DUAL
SURFACE CRYSTALLOGRAPHIC
ORIENTATIONS AND METHOD OF
FORMING SAME
First Named Inventor: Tenko Yamashita
Domestic/Foreign Application: Domestic Application
Filing Date: 2004-08-09
Effective Receipt Date: 2004-08-10
Submission Type: Information Disclosure
Statement
Filing Type:
Confirmation number: 9885
Attorney Docket Number: 50T5690.01

Total Fees Authorized:

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Office,ou=Department of Commerce,o=U.S. Government,c=US
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**TRANSMITTAL**

Electronic Version v1.1

Stylesheet Version v1.1.0

Title of Invention	SILICON-ON INSULATOR (SOI) SUBSTRATE HAVING DUAL SURFACE CRYSTALLOGRAPHIC ORIENTATIONS AND METHOD OF FORMING SAME																
<table><tr><td>Application Number:</td><td>10/800348</td><td></td></tr><tr><td>Date:</td><td colspan="2">2004-08-09</td></tr><tr><td>First Named Applicant:</td><td colspan="2">Tenko</td></tr><tr><td>Confirmation Number:</td><td colspan="2">9885</td></tr><tr><td>Attorney Docket Number:</td><td colspan="2">50T5690.01</td></tr></table>			Application Number:	10/800348		Date:	2004-08-09		First Named Applicant:	Tenko		Confirmation Number:	9885		Attorney Docket Number:	50T5690.01	
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<p>I hereby certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.</p> <p>I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.</p> <table border="1"><thead><tr><th>Submitted by:</th><th>Elec. Sign.</th><th>Sign. Capacity</th></tr></thead><tbody><tr><td>Keum J. Park Registered Number: 42059</td><td>/Keum J. Park/</td><td>Attorney</td></tr></tbody></table>			Submitted by:	Elec. Sign.	Sign. Capacity	Keum J. Park Registered Number: 42059	/Keum J. Park/	Attorney									
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<table><tr><td>Documents being submitted</td><td>Files</td></tr><tr><td>us-ids</td><td>3020-104IDS-usidst.xml</td></tr><tr><td></td><td>us-ids.dtd</td></tr><tr><td></td><td>us-ids.xsl</td></tr></table>			Documents being submitted	Files	us-ids	3020-104IDS-usidst.xml		us-ids.dtd		us-ids.xsl							
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Comments																	



THIS IDS IS BEING FILED UNDER 37 C.F.R. 1.97(b) before the mailing date of a first Office Action on the merits (37 C.F.R. 1.97(b)(3)). No fee or statement is required. If the Examiner has any questions concerning this IDS, he/she is requested to contact the undersigned. If it is determined that this IDS has been filed under the wrong rule, the PTO is requested to consider this IDS under the proper rule (with a petition if necessary) and charge the appropriate fee to Deposit Account No. 50-1047. If Applicant has overlooked any additional fees, or if any overpayment has been made, the Commissioner is hereby authorized to credit or debit Deposit Account 50-1047.



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of
Invention

SILICON-ON INSULATOR (SOI) SUBSTRATE HAVING
DUAL SURFACE CRYSTALLOGRAPHIC ORIENTATIONS
AND METHOD OF FORMING SAME

Application Number: 10/800348



Confirmation Number: 9885

First Named Applicant: Tenko Yamashita

Attorney Docket Number: 50T5690.01

Art Unit: 2812

Search string: (5841170 or 6391692 or 6476445 or 6503813
or 6559035 or 6566712 or 6593173 or 6627505
or 6649455).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5841170	1998-11-24	Adan et al.		257	345
	2	6391692	2002-05-21	Nakamura	B1	438	151
	3	6476445	2002-11-05	Brown et al.	B1	257	347
	4	6503813	2003-01-07	Koburger, III	B1	438	424
	5	6559035	2003-05-06	Villa et al.	B2	438	481
	6	6566712	2003-05-20	Hayashi et al.	B2	257	347
	7	6593173	2003-07-15	Anc et al.	B1	438	149
	8	6627505	2003-09-30	Adan	B2	438	311
	9	6649455	2003-11-18	Murakami	B2	438	149

Signature

Examiner Name	Date